

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chen et al

Serial No.: ~~(unknown)~~ 10/053785

Filed: ~~(herewith)~~ 1-18-02

For: A METHOD FOR ELECTROPLATING A  
BODY-CENTERED CUBIC NICKEL-IRON  
ALLOY THIN FILM WITH A HIGH  
SATURATION FLUX DENSITY

Group No.: 1741  
~~(unknown)~~

Examiner: ~~(unknown)~~ valentine

Docket No. SJO920000194US1

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

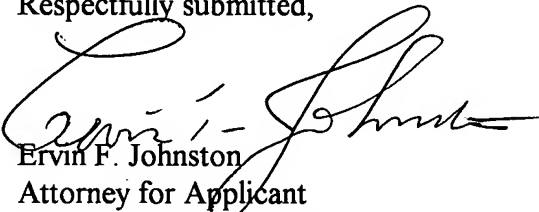
Applicants hereby cite the documents listed in accompanying Form PTO-1449 with respect to the above-referenced patent application under the provisions of 37 C.F.R., Sections 1.56, 1.97 and 1.98. Copies of the documents are attached.

The filing of this Information Disclosure Statement will not be construed to mean that a search was conducted or that no other material information, as defined by 37 C.F.R. 1.56, exists.

The Examiner is respectfully requested to make the listed documents of record in connection with the prosecution of the subject application.

Respectfully submitted,

Date: 11/5/01

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